

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Priority Application Serial No. ....09/352,817  
Priority Filing Date ..... July 13, 1999  
Inventor..... Eugene P. Marsh  
Assignee..... Micron Technology, Inc.  
Priority Group Art Unit ..... 1762  
Priority Examiner ..... B. Chen  
Attorney's Docket No. ....MI22-1786  
Title: Methods of Cleaning Vaporization Surfaces

**PRELIMINARY AMENDMENT**

To: Box PATENT APPLICATION  
Assistant for Patents and Trademarks  
Washington, D.C. 20231

From: James E. Lake (Tel. 509-624-4276; Fax 509-838-3424)  
Wells, St. John, Roberts, Gregory & Matkin P.S.  
601 W. First Avenue, Suite 1300  
Spokane, WA 99204-0317

**AMENDMENTS**

**In the title**

Please replace the title "Vapor Forming Devices, and Methods of Cleaning  
Vaporization Surfaces" with -- Methods of Cleaning Vaporization Surfaces --

**In the Specification**

At p. 1, before the "Technical Field" section, insert

**--RELATED PATENT DATA**

This patent resulted from a continuation application of U.S. Patent Application  
Serial No. 09/352,817, filed on July 13, 1999, <sup>now US Patent 6,318,381.</sup>  
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